

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Isamu Kobori et al. Art Unit: 2812

Serial No.: 10/623,581 Examiner: Stanetta Isaac Filed: July 22, 2003 Confirmation No.: 6534

Title : METHOD OF MANUFACTURING A SEMICONDUCTOR METHOD OF

MANUFACTURING A THIN-FILM TRANSISTOR AND THIN-FILM

**TRANSISTOR** 

## Mail Stop Amendment

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

## **AMENDMENT IN REPLY TO ACTION OF FEBRUARY 9, 2005**

Please amend the above-identified application as follows: